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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: SUGIYAMA et al.

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Title: EQUIPMENT AND METHOD FOR
MANUFACTURING SILICON CARBIDE
SINGLE CRYSTAL

Atty. Dkt.: 01-609

Art Unit: 1722

Examiner: Kunemund

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany St.
Alexandria, VA 22314

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RESPONSE UNDER 37 CFR 1.111

Sir:

In response to the office action mailed 27 June 2006, please enter the following remarks:

Remarks begin on page 2 of this paper.